## UTILITY PATENT APPLICATION TRANSMITTAL

(Only for new nonprovisional applications under 37 CFR 1.53(b))

Attorney Docket No.			401352	ુંટ
First Inventor		SHIN	TANI ET AL.	800
	Method of Fabricating Semiconductor			
	Device and Wafer Treatment			
	Apparatus Employed Therefor as well			
Title	as Semiconductor Device			

	Express Mail Label No.				
APPLICATION ELEMENTS	ADDRESS TO: Commissioner for Patents Box Patent Application Washington, DC 20231				
1. X Utility Patent Application Transmittal Form	ACCOMPANYING APPLICATION PARTS				
Applicant claims small entity status. See     37 CFR 1.27.      Specification (including claims and	<ol> <li>Applicant requests early publication. (include publication fee under 37 CFR 1.18(d))</li> </ol>				
Specification (including claims and abstract)	1. Is(d))  1.				
b. Specification Sequence Listing on: i. □ CD-ROM or CD-R (2 copies); or ii. □ Paper Copy c. □ Statement verifying identity of above copies					
21. If a CONTINUING APPLICATION, check appropriate box and supply the requisite information					
below:					
☐ Continuation ☐ Divisional ☐ Continuation-in-part of prior application no.					
Prior application information: Examiner ; Group Art Unit: 22. CORRESPONDENCE ADDRESS					
☐ Customer Number: 23548      ☐ 23548	☐ Jeffrey A. Wyand, Reg. No. 29,458 Leydig, Voit & Mayer, Ltd. Suite 300 700 Thirteenth Street, N.W. Washington, D.C. 20005-3960				
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Signature	Marie				
Date During O22 wor					